

Notice of References Cited	Application/Control No. 10/594,691	Applicant(s)/Patent Under Reexamination MIYAGAWA ET AL.	
	Examiner Arnel C. Lavarias	Art Unit 2872	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0077752	04-2004	Matsufuji et al.	524/037
*	B	US-2003/0158309	08-2003	Ono et al.	524/261
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	WO 2004000550 A1	12-2003	World Intellect	FUKUDA et al.	
	O					
	P					
	Q					
	R					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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